



MEMS/NEMS North America TC Chapter

NA Standards Winter Meetings 2026

Monday, February 9, 10:00–11:00 Pacific (OVTCCM)

AGENDA

	Time
1 Welcome/Call to Order	10:00
1.1 Please log into https://www.svm.semi.org/ for voting	
1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)	
1.3 Introductions	
1.4 Agenda Review	
2 Staff Report	10:10
3 Review of Previous Meeting Minutes	10:20
4 Ballot Review	10:25
4.1 Document 7370 — Reapproval of SEMI MS13-0221, Guide for Use of Test Patterns for Characterizing a Deep Reactive Ion Etching (DRIE) Process	
5 Task Force Updates	10:35
5.1 No TFs met at this meeting set.	
6 Old Business	10:35
6.1 Five-Year Review	
6.2 Task Force re-organization discussion	
7 New Business	10:45
Survey completed by MSIG asking for top topics to work on. The top three are as follows:	
• MEMS processing tutorials • Heterogeneous integration • White paper on diagnosing tests and reliability failures • Integration of new materials into fab	



Time

8 Action Item Review

10:55

8.1 SEMI, MSIG; How to increase participants in SEMI Standards, WGs, WG meeting, and to other events?

- Social media posts, MSEC ??
- Incentives to join?

8.2 New A/I:

- Review existing MEMS TFs with MSIG (plan to disband, rename, and change leadership)
 - ongoing

1 Next Meeting and Adjournment

11:00

1.1 The next SEMI Standards NA Meetings are tentatively scheduled for the week of May 11-14, 2026, to be held in-person and virtually in conjunction with ASMC in Albany, New York. Schedule details TBD. <https://www.semi.org/en/products-services/standards>.

Tentative Schedule:

- Monday or Thursday
 - ???, MEMS/NEMS NA TC Chapter

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